

Form PTO-1449

Document Number (Optional)

TSMC-99-431/909 10/706, 382

Application Number

Applicant Wen-Jui Fu et al.

Filing Date

11/12/03

Group Number

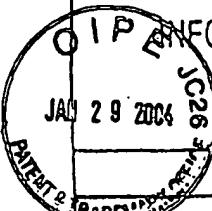
2813

JAN 29 2006

## O I P INFORMATION DISCLOSURE CITATION

## IN AN APPLICATION

(Use several sheets if necessary)



## U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	PUBLISH DATE IF APPROPRIATE
SL	6162733	12/19/00	Obeng	438	706	1/15/99
	60632075	16/00	Yu et al.	134	2	2/1/99
	5824234	10/20/98	Jou et al.	216	18	10/2/98
	5380401	11/10/95	Jones et al.	156	665	1/14/93
	5970376	10/19/99	Chen	438	637	12/29/97
	5755891	5/26/98	Lo et al.	134	1.2	1/24/97
	57700986	6/23/98	Araki et al.	216	67	3/16/94
	59424468	24/99	Chen et al.	438	734	9/12/97
	57768327	7/7/98	Hsieh et al.	438	669	7/17/96
	6136680	10/24/00	Lai et al.	438	597	1/21/00
SL	5854134	12/29/98	Lan et al.	438	695	5/5/97

## FOREIGN PATENT DOCUMENTS

DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
					YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Page or Pages, Etc.)


EXAMINER	DATE CONSIDERED
heena Schels	9/6/05

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.

